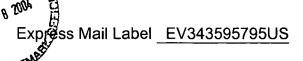
Attorney Docket No. 29195-8170US2 Semitool Ref No. P99-0006US3



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: THOMAS L. RITZDORF ET AL.

EXAMINER:

LEADER, WILLIAM T.

APPLICATION NO.:

09/885,451

ART UNIT: 1742

3390

FILED:

JUNE 20, 2001

CONF. No:

FOR: METHOD AND APPARATUS FOR LOW

TEMPERATURE ANNEALING OF

METALLIZATION MICRO-STRUCTURES IN

THE PRODUCTION OF A MICROELECTRONIC DEVICE

Information Disclosure Statement Within Three Months of Application Filing or Before First Action – 37 C.F.R. § 1.97(b)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

1. <u>Timing of Submission</u>

This information disclosure is being filed within three months of the filing date of this application or date of entry into the national stage of an international application or before the mailing date of a first Office action on the merits, whichever occurs last [37 C.F.R. § 1.97(b)]. The references listed on the enclosed Form PTO-1449 (modified) may be material to the examination of this application; the Examiner is requested to make them of record in the application.

2. Cited Information

☑ All cited references☐ References marked by asterisks☐ The following:	\boxtimes

Attorney Docket No. 29195-8170US2 Semitool Ref No. P99-0006US3 Copies of the following references can be found in parent U.S. Application No. All cited references References marked by asterisks The following: \Box This application was filed after 30 June 2003 and no copies of U.S. patents nor published applications are enclosed (See Notice of Deputy Commissioner Kunin on 11 July 2003). The following references are not in English. For each such reference, the undersigned has enclosed (i) a translation of the reference; (ii) a copy of a

The following references are not in English. For each such reference, the undersigned has enclosed (i) a translation of the reference; (ii) a copy of a communication from a foreign patent office or International Searching Authority citing the reference, (iii) a copy of a reference which appears to be an English-language counterpart, or (iv) an English-language abstract for the reference prepared by a third party. Applicant has not verified that the translation, English-language counterpart or third-party abstract is an accurate representation of the teachings of the non-English reference, though, and reserves the right to demonstrate otherwise.

☐ All cited references☐ References marked by ampersands☐ The following:

3. Effect of Information Disclosure Statement (37 C.F.R. § 1.97(h))

This Information Disclosure Statement is not to be construed as a representation that: (i) a search has been made; (ii) additional information material to the examination of this application does not exist; (iii) the information, protocols, results and the like reported by third parties are accurate or enabling; or (iv) the cited information is, or is considered to be, material to patentability. In addition, applicant does not admit that any enclosed item of information constitutes prior art to the subject invention and specifically reserves the right to demonstrate that any such reference is not prior art.

4. <u>Fee Payment</u>

No fees are believed due because this Information Disclosure Statement is being filed before the mailing date of the first Office Action.

			submits 37 C.F.I							_	of	the	follow	ing
	In acco	ordan	ce with	37 C.	F.R.	§ 1.	.97	(e)(1)), th	e uno	ders	signe	ed here	eby

states that each item of information submitted herewith was cited in a communication from a foreign patent office in a counterpart

Attorney Docket No. 29195-8170US2 Semitool Ref No. P99-0006US3

foreign application not more than three months prior to the filing of this statement; or

In accordance with 37 C.F.R. § 1.97(e)(2), the undersigned hereby states that no item of information submitted herewith was cited in a communication from a foreign patent office in a counterpart foreign application, or, to the knowledge of the person signing the certification after making reasonable inquiry, was known to any individual designated in 37 C.F.R. § 1.56(c), more than three months prior to the filing of this statement.

However, should the Commissioner determine that fees are due in order for this Information Disclosure Statement to be considered, the Commissioner is hereby authorized to charge such fees to Deposit Account No. 50-0665.

- 5. Patent Term Adjustment (37 C.F.R. § 1.704(d))
 - The undersigned states that each item of information submitted herewith was cited in a communication from a foreign patent office in a counterpart application and that this communication was not received by any individual designated in 37 C.F.R. § 1.56(c) more than thirty days prior to the filing of this statement. 37 C.F.R. § 1.704(d).

Respectfully submitted, Perkins Coie LLP

Date: March 15, 2004

Paul T. Parker

Registration No. 38,264

Correspondence Address:

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CIPE				COMPLETE IF KNOWN				
	INFORMATION			Application Number	09/885,451			
4000	PINFORMATION	DISCLOSURE		Confirmation Number	3390			
MAR 1 0 5	Ħ	ALL EIGAN		Filing Date	June 20, 2001			
MAR 1	Form PTO-14	49 (Modified)		First Named Inventor	Thomas Ritzdorf			
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Sheet	1	of	1	Attorney Docket No.	29195-8170US2			

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EXAMINER		DATE CONSIDERED					
*EXAMINER:	Initial if reference considered, whether or not criteria is in conformance with MPEP 609. Draw line through citation if not in conformance and not						
	considered. Include copy of this form with next communication to application(s).						